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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seleznev, *et al.* Examiner: To be assigned

Serial No.: 10/799,436 Art Unit: 1751

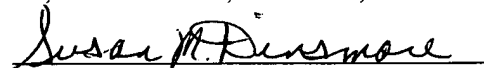
Filing Date: March 12, 2004

Title: VACUUM PROCESSING FOR FABRICATION OF
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-
ORGANIC PROCESSING

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450
Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on February 25, 2005


Susan M. Dinsmore

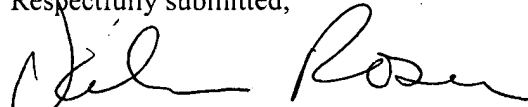
TRANSMITTAL

Enclosed herewith please find:

1. Preliminary Amendment (9 pgs.);
2. Statement Filed Pursuant to the Duty of Disclosure Under 37 CFR §§1.56, 1.97 and 1.98 (5 pgs.);
3. Form PTO-1449 (3 pgs.);
4. Cited art; and
5. Return postcard.

Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

Respectfully submitted,



Valarie B. Rosen
Registration No.: 45,698

Choate, Hall & Stewart, LLP
Exchange Place
53 State Street
Boston, MA 02109
(617) 248-5000
Dated: February 25, 2005